

Form PTO-1449 U.S. Department of Commerce (Rev. 8-88) Patent and Trademark Office				Attorney Docket No.: 1201.68303		Serial No.: Unassigned	
INFORMATION DISCLOSURE CITATION (Use several sheets if necessary).				Applicant: Liu et al.			
				Filing Date: Herewith		Group: Unassigned	
U.S. PATENT DOCUMENTS							
Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
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						Yes	No
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↑	Jin Zhu, "Chemical and physical methods for the modification of high-temperature superconductors, nanoparticles and other inorganic substrates (Abstract)", The Sciences and Engineering, Vol. 60-12B, pp.6102, 1999.						
	Dana A. Weinberger, Seunghun Hong, Chad A. Mirkin, B.W. Westels, Thomas B. Higgins, "Combinatorial generation and analysis of nanometer-and micrometer-scale silicon features via 'dip-pen' nanolithography and wet chemical etching", Advanced Materials, Vol. 12, No. 21, pp. 1600-1603, November 2000.						
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↓	Michael Gross, "Incredible nanoplotter", Chemistry in Britain, Vol. 36, No. 10, p. 25, October 2000.						
PD	S. Hong, J. Zhu, C.A. Mirkin, "Multiple ink nanolithography: toward a multiple-pen nano-plotter", Science, Vol. 286, No. 5439, pp. 523-5, Oct. 15, 1999.						
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*Examiner: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							